



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: HIMI et al.

Serial No.: 10/716,606

Filed: 11/20/2003

Title: METHOD FOR MANUFACTURING  
SEMICONDUCTOR SUBSTRATE

Atty. Dkt.: 01-100-DIV

Art Unit: 2813

Examiner: Thanhha S. PHAM

**Mail Stop Amendment**

Commissioner for Patents  
U.S. Patent and Trademark Office  
Customer Window  
Randolph Building  
401 Dulany St.  
Alexandria, VA 22314

Date: 31 October 2006

**AMENDMENT UNDER 37 CFR 1.111**

Sir:

In response to the office action mailed 2 June 2006, please amend the application as follows:

**Amendments to the Claims** are reflected in the listing of claims that begins on page 2 of this paper.

**Remarks** begin on page 8 of this paper.